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CONFIRMATION NO. 7946

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10/543,166		257	2891	ISH-0234

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** CONTINUING DATA *****

This application is a 371 of PCT/JP04/00869 01/29/2004

** FOREIGN APPLICATIONS *****

JAPAN 2003-030642 02/07/2003

** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		JAPAN	9	9	2

ADDRESS

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TITLE

Silicon semiconductor substrate and its manufacturing method

FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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